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(11) **EP 1 221 711 A2**

(12) **EUROPEAN PATENT APPLICATION**

(43) Date of publication:
10.07.2002 Bulletin 2002/28

(51) Int Cl.7: **H01J 17/04, H01J 17/20,
H01J 17/49, H01J 9/02**

(21) Application number: **02006620.5**

(22) Date of filing: **13.12.1996**

(84) Designated Contracting States:
DE FR GB IT

(30) Priority: **15.12.1995 JP 32676695
01.02.1996 JP 1632696
24.06.1996 JP 16263996
26.08.1996 JP 22342896**

(62) Document number(s) of the earlier application(s) in
accordance with Art. 76 EPC:
**01116788.9 / 1 164 620
96309148.3 / 0 779 643**

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Remarks:

This application was filed on 25 - 03 - 2002 as a
divisional application to the application mentioned
under INID code 62.

(54) **Plasma display panel suitable for high-quality display and production method**

(57) The first object of the present invention is to provide a PDP with improved panel brightness which is achieved by improving the efficiency in conversion from discharge energy to visible rays. The second object of the present invention is to provide a PDP with improved panel life which is achieved by improving the protecting layer protecting the dielectrics glass layer. To achieve the first object, the present invention sets the amount of xenon in the discharge gas to the range of 10% by volume to less than 100% by volume, and sets the charging pressure for the discharge gas to the range of 500 to 760 Torr which is higher than conventional charging pressures. With such construction, the panel brightness

increases. Also, to achieve the second object, the present invention has, on the surface of the dielectrics glass layer, a protecting layer consisting of an alkaline earth oxide with (100)-face or (110)-face orientation. The protecting layer, which may be formed by using thermal Chemical Vapor Deposition (CVD) method, plasma enhanced CVD method, or a vapor deposition method with irradiation of ion or electron beam, will have a high sputtering resistance and effectively protect the dielectrics glass layer. Such a protecting layer contributes to the improvement of the panel life.

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